



PATENT
Attorney Docket No. A-70092/RMA/JML (469090-14)

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re application of: KAJIWARA, et al. Serial No.: 09/874,174 Filing Date: 4 JUNE 2001 For: CHEMICAL MECHANICAL POLISHING APPARATUS AND METHOD HAVING A RETAINING RING WITH A CONTOURED SURFACE	Examiner: MORGAN, EILEEN P Group Art Unit: 3723 <u>CERTIFICATE OF MAILING</u> I hereby certify that this correspondence and its listed enclosures is being deposited with the United States Postal Service as First Class Mail addressed to Commissioner for Patents; P.O. Box 1450; Alexandria, VA 22313-1450 on <u>April 9, 2004</u> . Signed <u>Wendy Wilson</u> Wendy Wilson
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PETITION FOR EXTENSION OF TIME

Commissioner for Patents
P.O. Box 1450
Alexandria, VA 22313-1450

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TECHNOLOGY CENTER 3700

Sir:

Applicants hereby request that the time to file a response to the Restriction Requirement mailed 11 February 2004 be extended by one month up to and including April 11, 2004. The \$110.00 fee pursuant to 37 C.F.R. 1.17(a)(1) is enclosed herewith.

The Commissioner is hereby authorized to charge any additional fees that may be due, including extension fees, or credit any overpayment to Deposit Account 50-2319 (Order No. A-70092/RMA/JML (469090-14)).

Respectfully submitted,

DORSEY & WHITNEY LLP

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Filed under 37 C.F.R. §1.34(a)

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